



Attorney Docket SEL 238

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)
Hiroki et al.)
Serial No.: 09/776,472)
Filed: February 2, 2001)
For: Thin Film Formation Apparatus And)
Method Of Manufacturing Self-Light-)
Emitting Device Using Thin Film)
Formation Apparatus)
Art Unit: 1762)
Examiner: M. Cleveland)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being
deposited with the United States Postal Service as first
class mail in an envelope addressed to:
Commissioner for Patents, P.O. Box 1450,
Alexandria, VA 22313-1450 on

March 8, 2004

(Date of Deposit)

Shannon Wallace

Name of applicant, assignee, or Registered Rep.

Shannon Wallace *3/8/04*

Signature

Date

AMENDMENT D

Sir:

In response to the Office Action of November 6, 2003, a one month extension of time being
submitted herewith, please amend the above-identified application as follows: